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Docket No.: R2180.0159/P159
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kazunari Kimino

Application No.: 10/609,634

Confirmation No.: 4954

Filed: July 1, 2003

Art Unit: 1734

For: APPARATUS AND METHOD FOR
MANUFACTURING SEMICONDUCTOR
DEVICE

Examiner: George R. Koch

DO NOT ENTER
GRK
6/22/06

AMENDMENT AFTER FINAL

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated March 15, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 9 of this paper.